

Piezo Force Sensor FTC408

Piezoelectric sensor for measuring deformation forces, e.g. during the crimping process. The sensor generates a voltage, which is transmitted via an electrode to the integrated charge amplifier. In combination with a crimp force monitor, the sensor is ideally suited for quality monitoring during the crimping process. The sensor can either be embedded in the ram or in the base plate of a crimping press.

Performance features

- Rugged and solid construction
- Exceptional stability and repeatability
- Built-in type amplifier to operate by a constant-current signal
- Wide linear dynamic measurement range
- High overload stability
- 8 BNC connection
- Measurement range up to 40 kN
- With screwed cable



Technical data

 Measurement range Sensitivity Temperature range Output impedance 	up to 40 kN 0.128 mV/N +/- 10% -20°C to +80°C < 100 Ohm
Output impedance	< 100 Ohm
Output DC Voltage	11 V ± 2 V

